

METHOD FOR FABRICATING A MASK READ-ONLY-MEMORY WITH DIODE CELLS

Inventor: Chun-Pei WU

Docket No. 4425-317

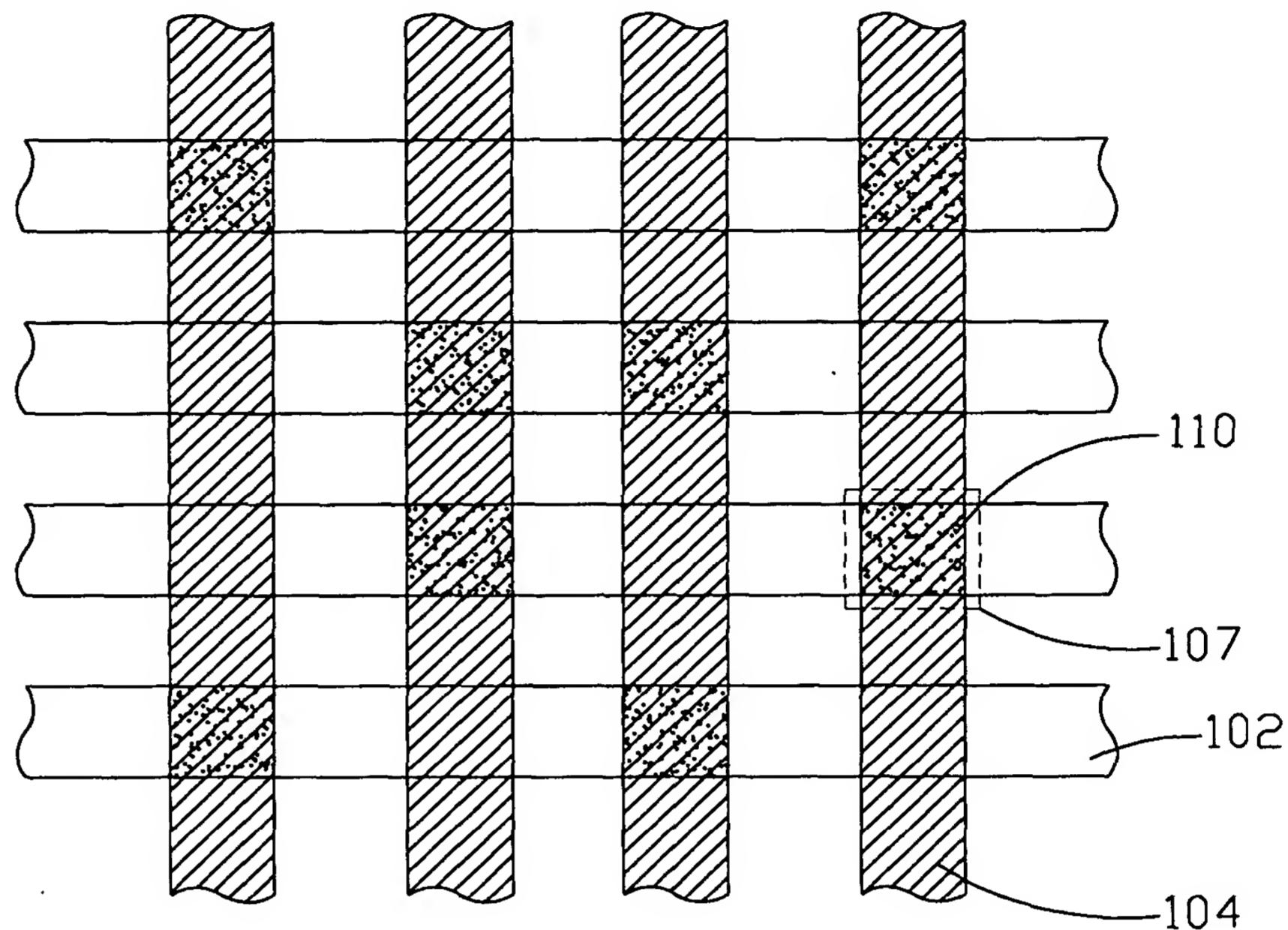


FIG.1A(Prior Art)

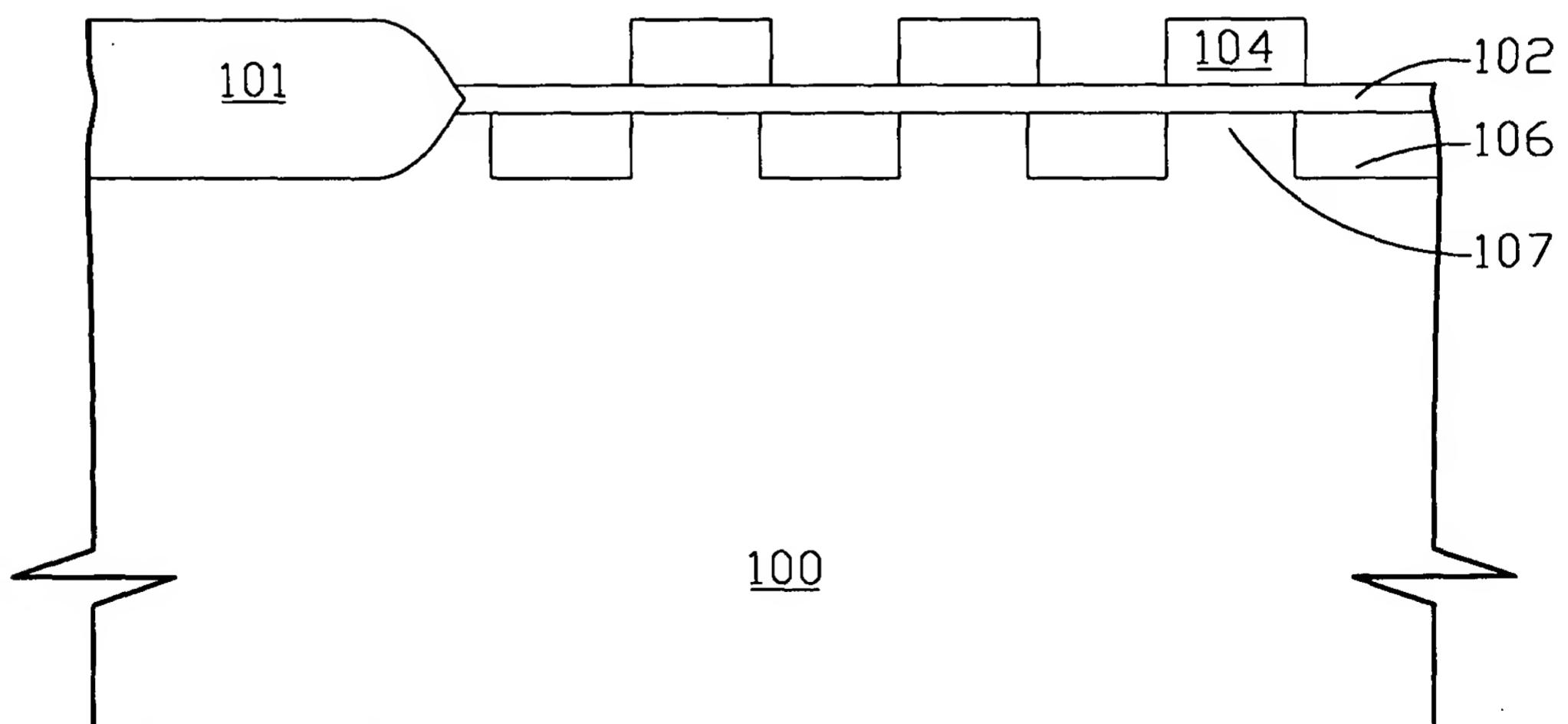


FIG.1B(Prior Art)

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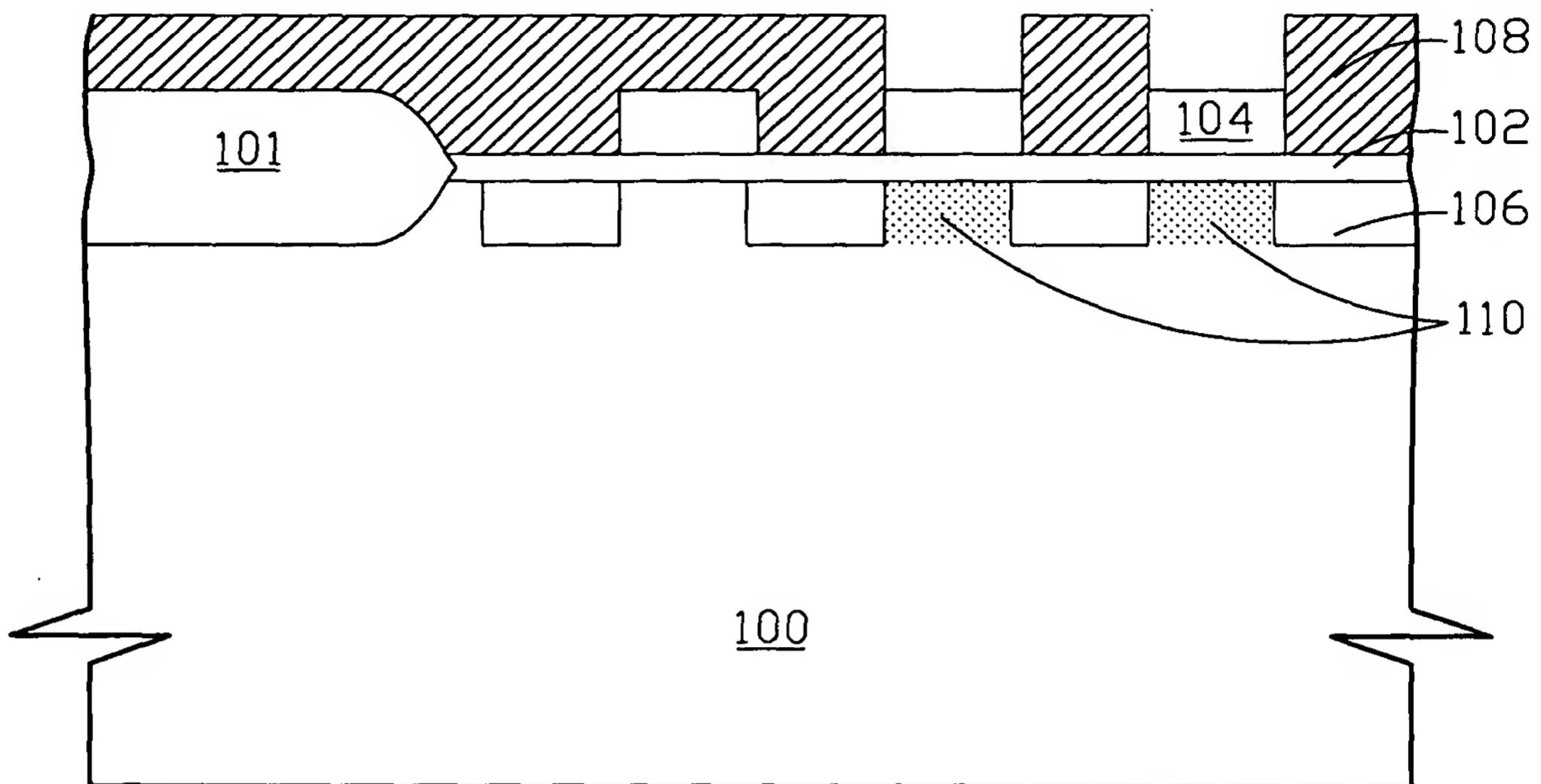


FIG.1C(Prior Art)

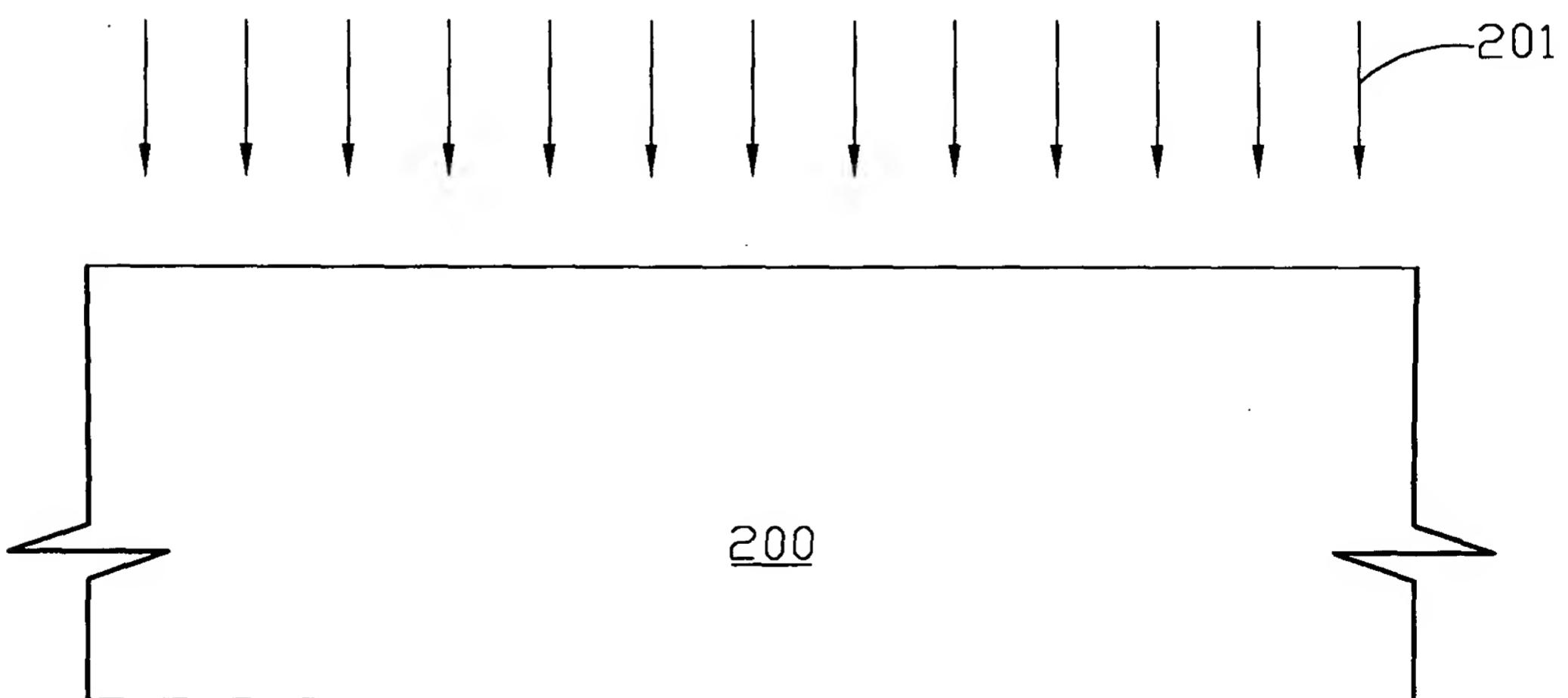


FIG.2A

METHOD FOR FABRICATING A MASK READ-ONLY-MEMORY WITH DIODE CELLS

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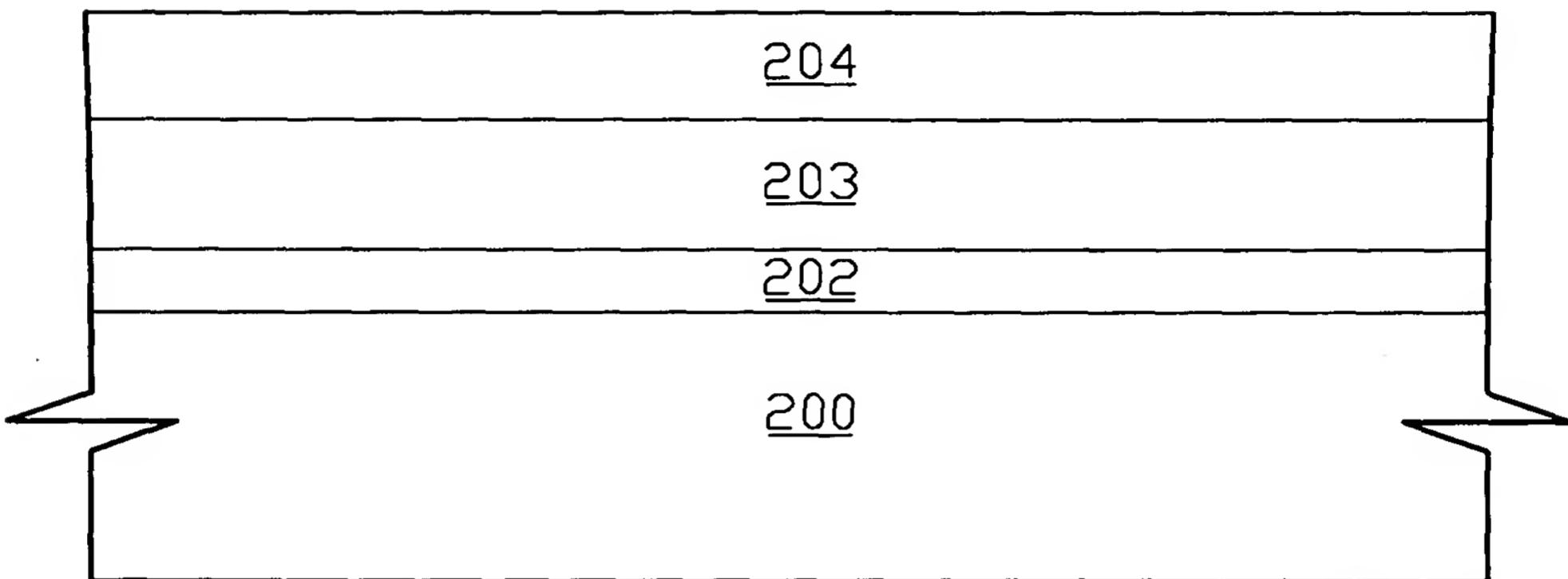


FIG.2B

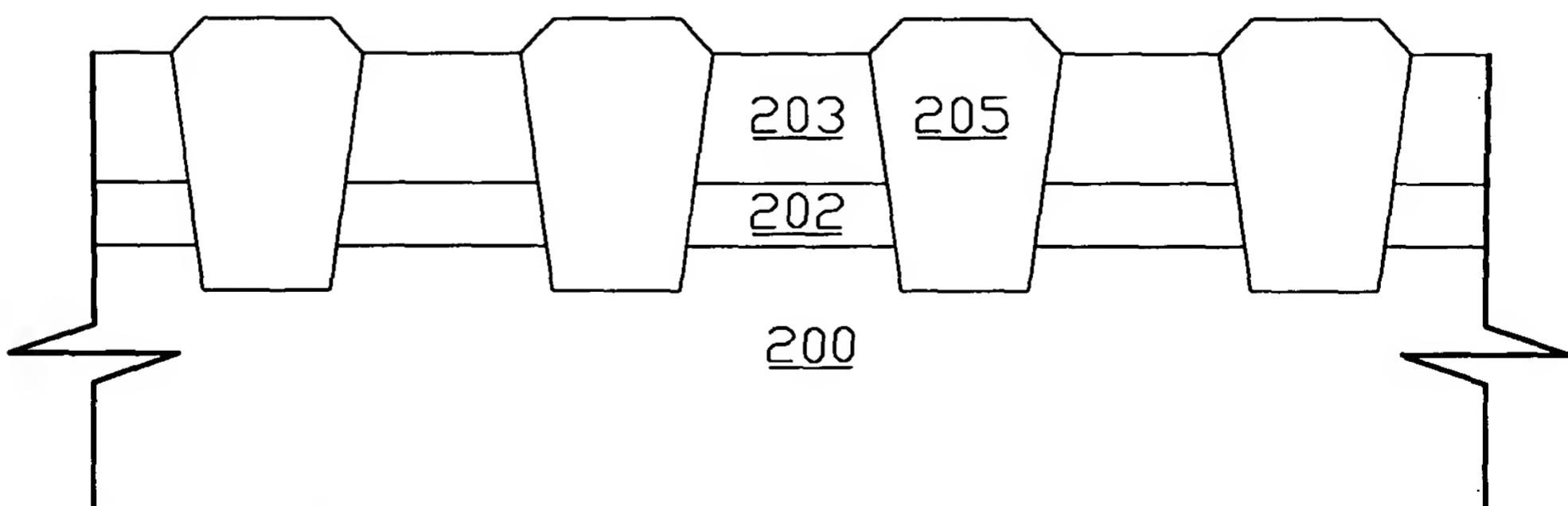


FIG.2C

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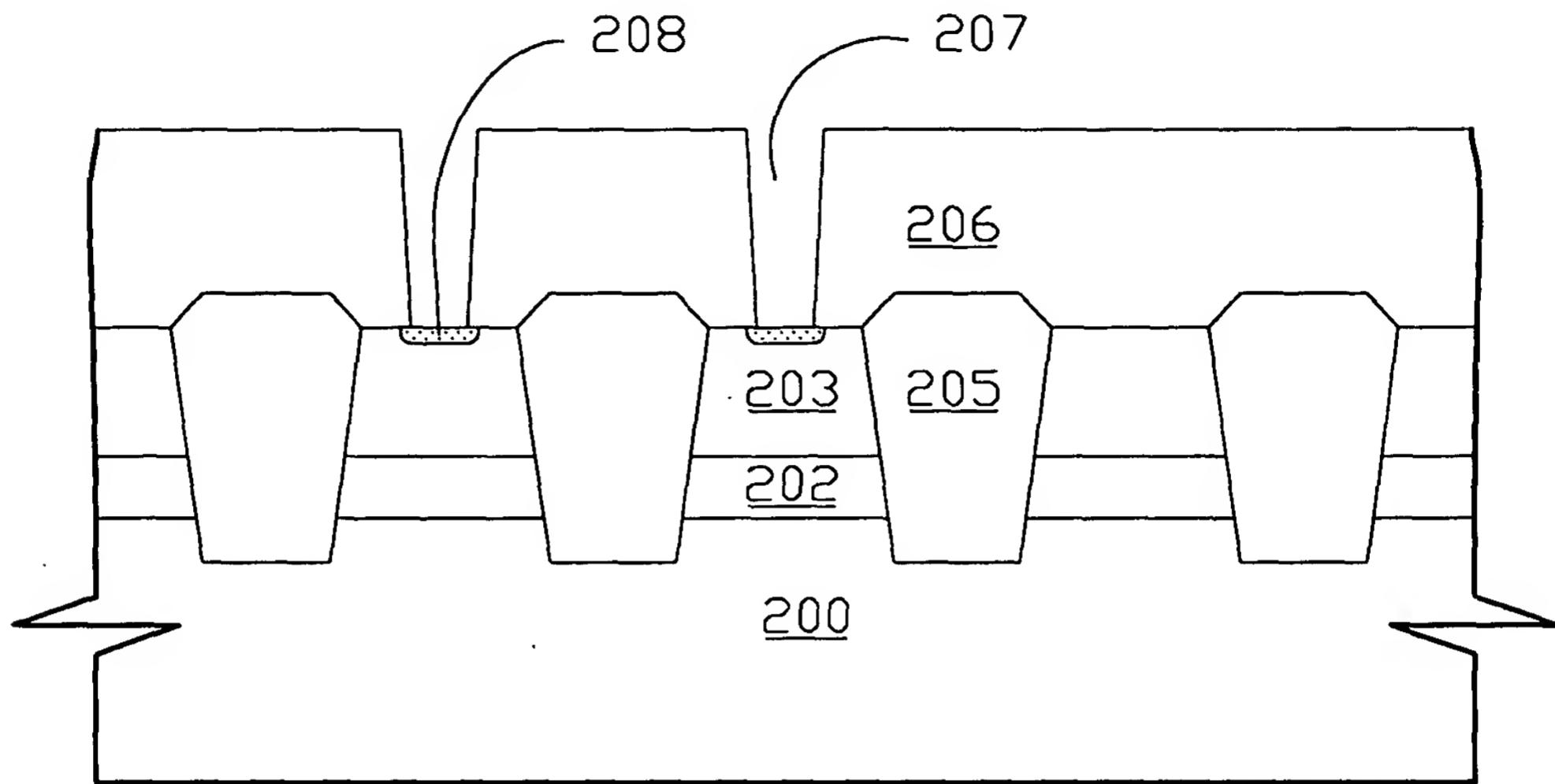


FIG.2D

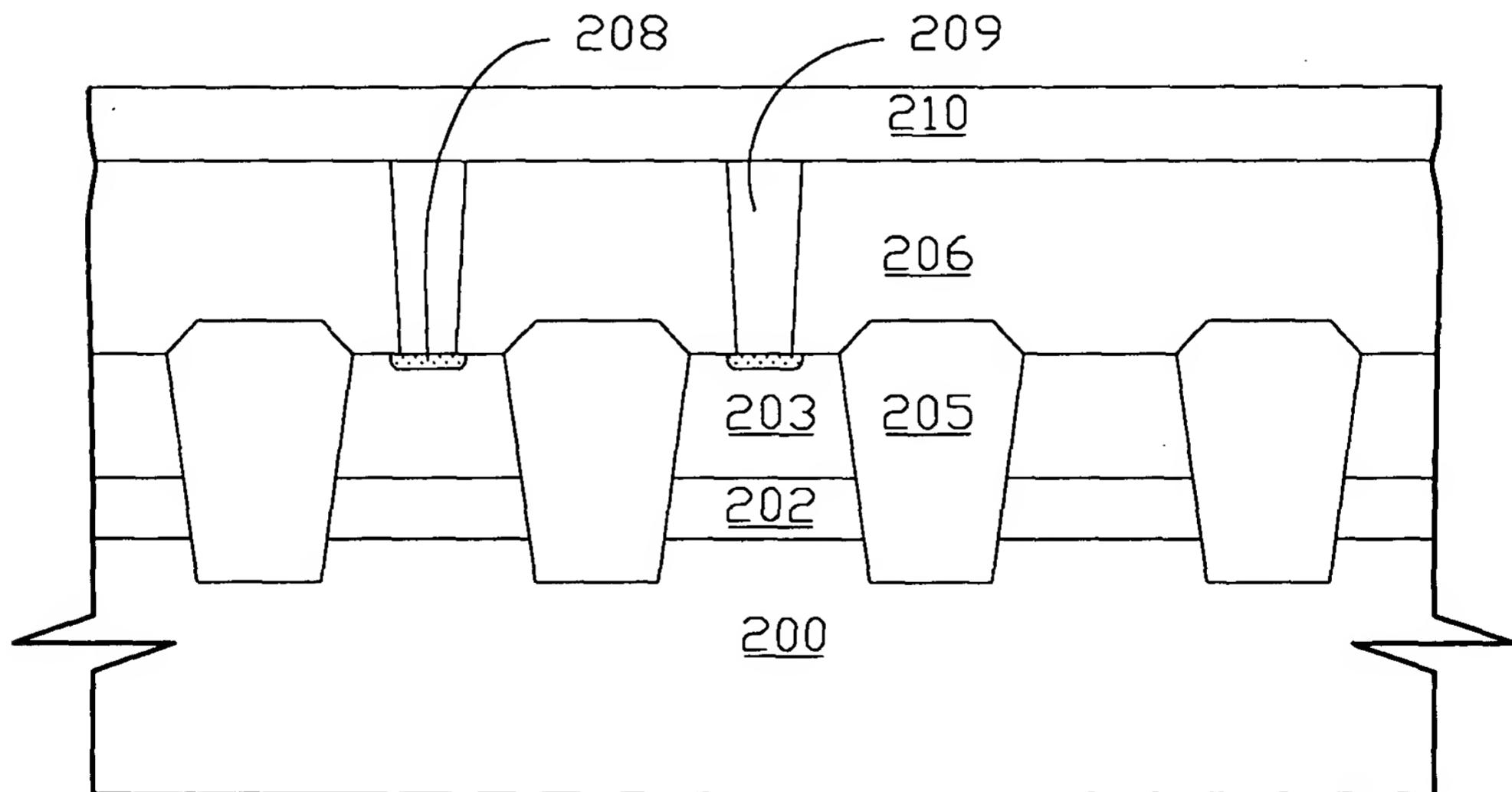


FIG.2E